IEEE SYSC/CEDA TCCPS Industrial Technical Excellence Award

The IEEE SYSC/CEDA TCCPS Industrial Technical Excellence Award recognizes a team of individuals who have conducted a substantive project which made exemplary contributions in terms of technology transfer of advanced cyber-physical system (CPS) technologies or the closely related enabling technologies at the national and/or international level. Through this project, the awardee is expected to make a distinguishing impact of technology transfer with documented evidence. The award consists of a plaque and a citation.

Eligibility
The main candidate in the team must be an IEEE member in good standing. Current members of IEEE TCCPS Award Committee are ineligible for the award.

Nomination:
The nomination should be proposed by someone who is familiar with the team and the project being nominated. The nomination package must be emailed to the TCCPS industrial award chair (Subject: IEEE TCCPS Industrial Technical Excellence Award), including the following details:

- Nominee(s): list name, affiliation, postal address, email address, and phone number.
- Nominator: list name, affiliation, postal address, email address, and phone number.
- Citation: provide a brief citation (35 words or less) precisely stating the significant industrial impact of the project.
- Nomination letter: describe the significant contributions and impacts in terms of technology transfer.
- Support letter(s): provide the evidences or official reports from the third parties to demonstrate the societal impact of the technology transfer and the revenue generated from the industrial deployment of the project outcomes.

Schedule:
Nomination needs to be submitted to Award Chair Prof. Dacheng Tao at dacheng.tao@sydney.edu.au by February 28th, 2020.